

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Rule 53(b) Divisional Application of:

Hirotoishi KUBO et al.

Divisional of S.N. 09/161,828 filed September 29, 1998

Group Art Unit: To Be Assigned

Filed: Herewith

Examiner: To Be Assigned

For: **SEMICONDUCTOR DEVICE AND A METHOD OF FABRICATING THE SAME**

INFORMATION DISCLOSURE STATEMENT
PURSUANT TO 37 CFR 1.97(b)

Commissioner for Patents
Washington, D.C. 20231

November 19, 2001

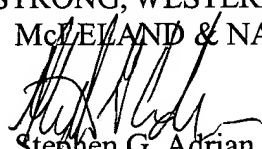
Sir:

This Information Disclosure Statement is being filed in order to comply with Applicants duty of disclosure under 37 CFR 1.56. The documents listed on the Form PTO-1449 were made of record in parent application Serial No. 09/161,828 filed September 29, 1998.

The Commissioner is authorized to charge our Deposit Account No. 01-2340 for any fee which is deemed by the Patent and Trademark Office to be required to effect consideration of this statement.

Respectfully submitted,

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